Microanalysis and Nano-Characterization of Materials: Where should CINT go?

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Introductory Notes:

- ➤ The CMM in the FSMRL (http://ntweb.mrl.uiuc.edu/cmm/) is a great template for a User Facility.
- Many laboratories have been patterned after the CMM-FSMRL

Outline:

- 1. Brief description of the CMM-FSMRL, and why it is successful.
- 2. What YOU want to see in CINT (open discussion / e-mail me: lhg@uiuc.edu).



Center for Microanalysis of Materials (CMM) Frederick Seitz Materials Research Laboratory (DoE - BES National User Facility)

An integrated facility with 24 hour access to qualified users. No user fees for non-proprietary research regardless of funding source

1. Electron Microscopy Transmission Electron Microscopy Philips EM420 Philips CM12 Hitachi H9000 **JEOL 4000EX*** Vacuum Generator HB501 JEOL 2010 F STEM/TEM **JEOL 2010 TEM Scanning Electron Microscopy SEM/Focused ion-beam microscopy** Hitachi S-4700 Zeiss 960/CL Low Energy Electron Microscopy IBM LEEM* 2. Ion-Beam Analysis HV Van de Graaff General Ionex Tandetron/XRD*

*in-situ science

3. Surface Analysis Cameca IMS 5f SIMS PHI TRIFT III TOF SIMS PHI 660 Auger **PHI 5400 XPS Surface Science XPS* Small-spot imaging XPS*** 4. Scanning Probe Microscopy **Digital Instruments Dimension AFM** Digital Instruments MultiMode AFM Omicron VT-UHV STM* **UHV-AFM* Near-Field Scanning Optical Microscopy*** 5. X-ray Scattering Philips X'pert Philips X'pert Rigaku RU 200 Rigaku D-Max **Scintag Powder PAD-X Energy Dispersive X-Ray Fluorescence** Small-angle X-ray scattering*



Frederick Seitz Materials Research Laboratory (Outside the CMM)

Synchrotron Beamlines

UNICAT at Advanced Photon Source/ANL

Sector 33 Insertion Device Beamline

Sector 33 Bending Magnet Beamline for XAFS

Sector 34 Insertion Device Beamline

Brookhaven NL

X16A *in-situ* UHV treatments X16C kappa diffractometer

Laser Facility

Absorption/Transmission Spectroscopy

Brillouin Spectroscopy

Photoluminescence

Raman Spectroscopy

Time-resolved fluorescence

Ellipsometry

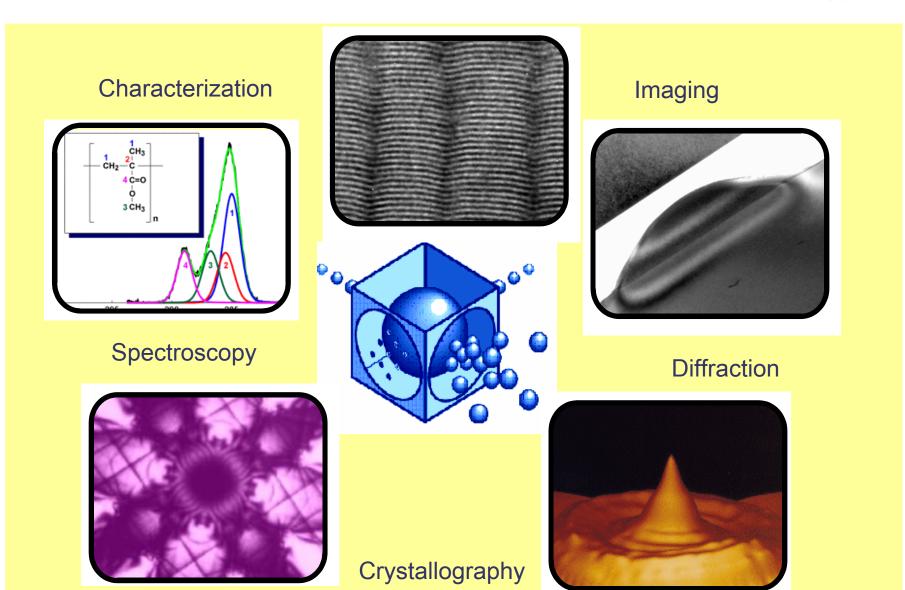
Magnetic Characterization Facility (SQUID)

MPMS system and PPMS system (T=1.9 – 800 K; ac or dc B<7T.)

Hall effect (T and B dependent)

Center for Microanalysis of Materials (CMM)

National User Center for Electron-Beam Microcharacterization Division of Materials Sciences, United States Department of Energy



Why use the Center for Microanalysis of Materials? (we ask this about CINT at the end)

> <u>Versatility</u>.

Broad spectrum of advanced analytical instrumentation and techniques.

Expertise and Flexibility

Staff are experts in techniques and in education / training. Scientists can learn to use facilities on their own, or in collaboration with a staff member.

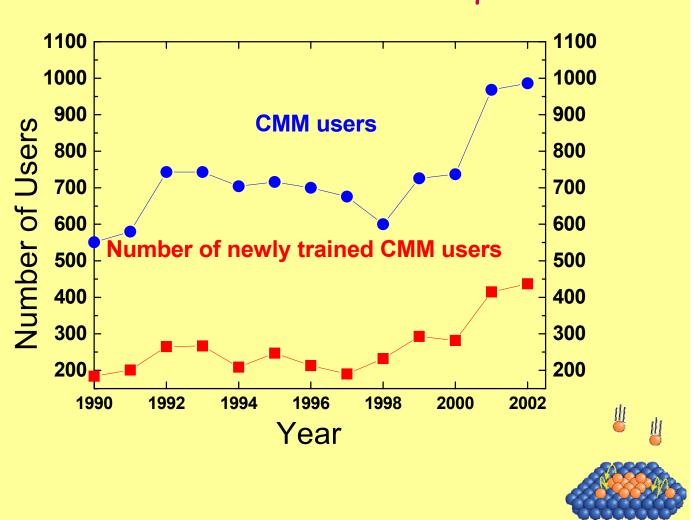
> Accessibility:

Open to internal and external users. Some techniques can be used on-line as well as on-site. Staff are available onsite and through the internet



Frederick Seitz Materials Research Laboratory Center for Microanalysis of Materials (CMM)

CMM is the single largest producer of scientists educated in nano-characterization techniques.



Why use CINT?

What will make CINT a unique center, whose existence is crucial to addressing new challenges in nanoscale characterization?

- 1. What do the you (the users of CINT) Want and Need?
- 2. What will make **you** come to CINT?
- 3. What will make LANL and SNL scientists want to work with **you**, the outside users?
- 4. How about Experimental Workshops, along the line of KITP Theoretical workshops? (Bring together groups of scientists, over weeks, to work with the CINT facilities on a common problem.) Would you be a co-PI on such a proposal?

Your input is crucial in this early stage